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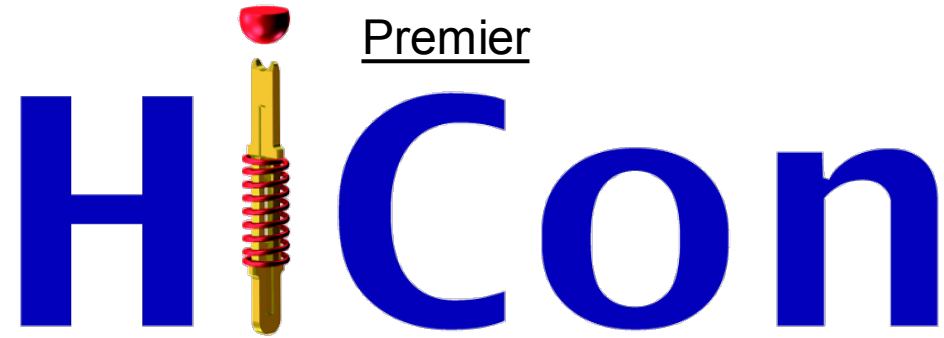
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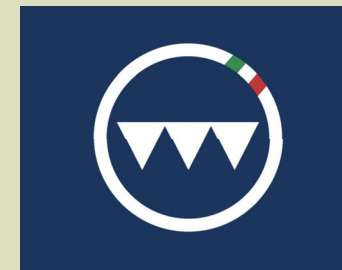
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Multi-disciplinary approach for the development of a MEMS Spring Probe for high frequency application

**Nadia Paderno, Francesco Signorello, Jacopo Martelli
Technoprobe S.p.A.**



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Introduction

- Process of continuous iteration
- Synergy
- Targets
 - 300 um pitch
 - Up to 35 GHz
 - Force > 8 g
 - Test height < 3 mm
 - Layout

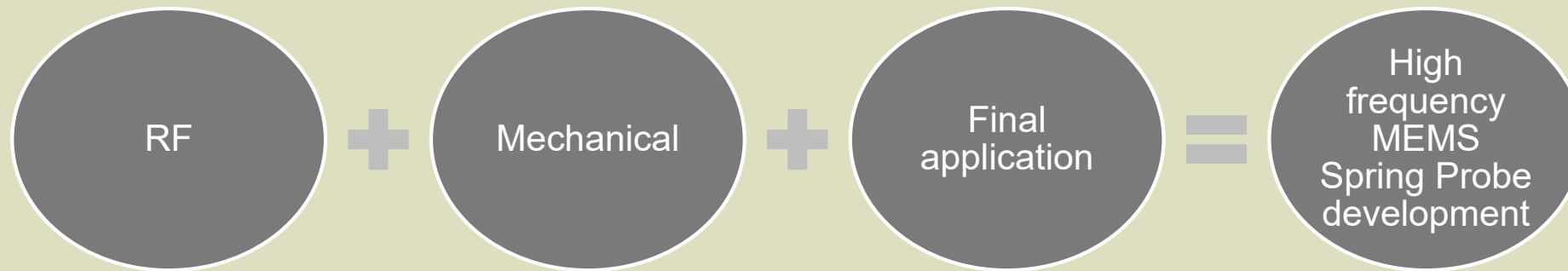


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Introduction

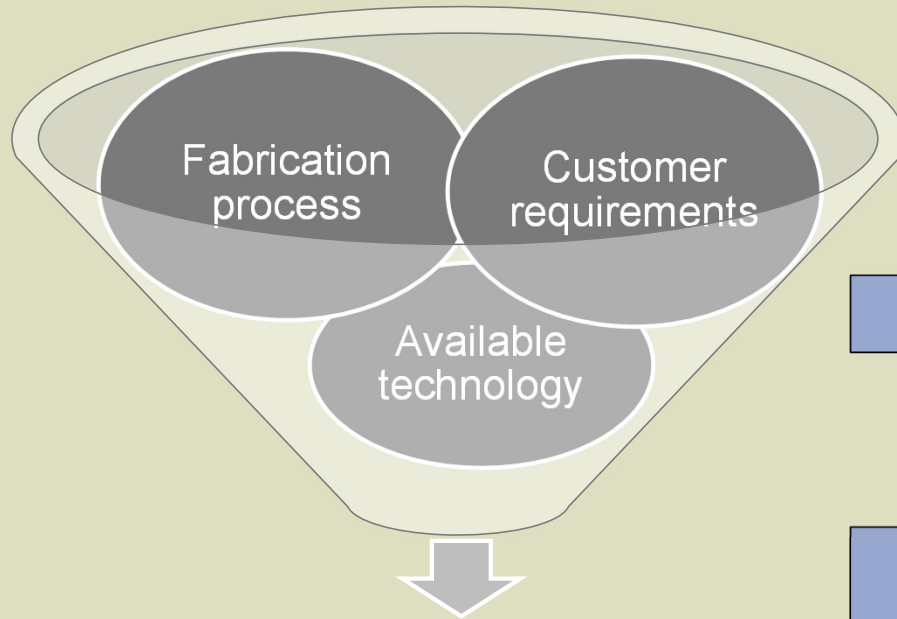


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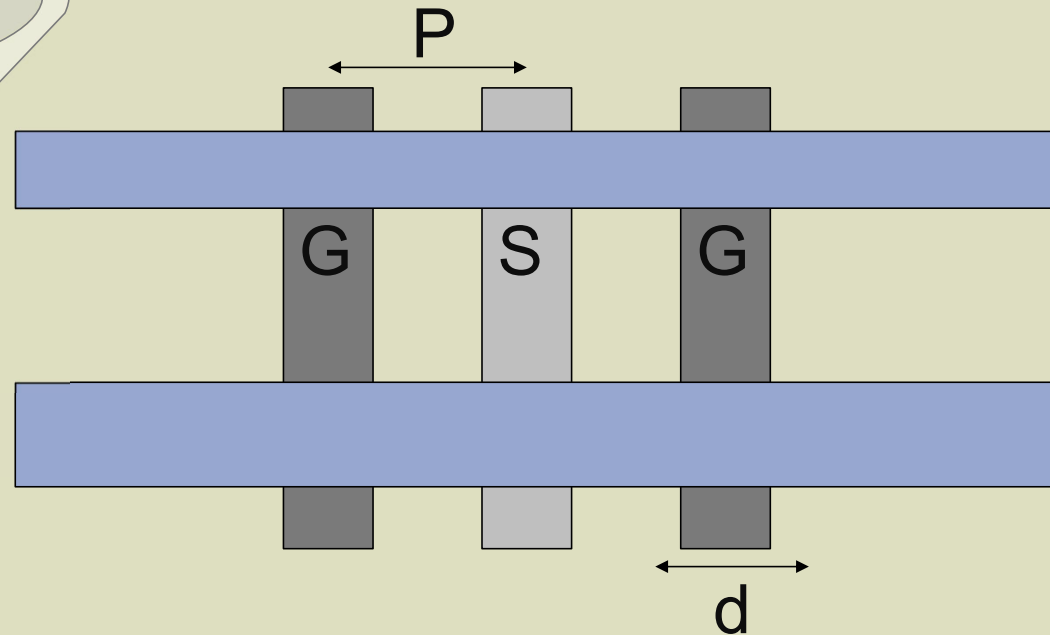
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Primitive Mechanical Structure



- Minimum pitch (P)
- Layout
- Max holes dimension (d)



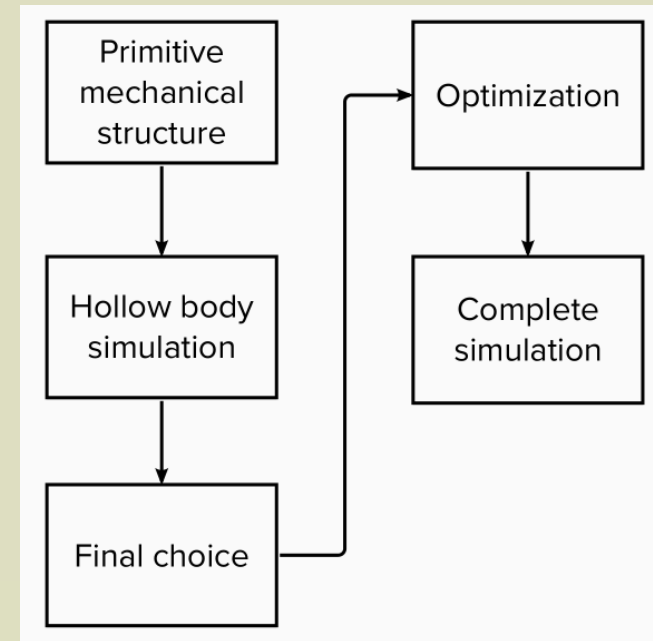
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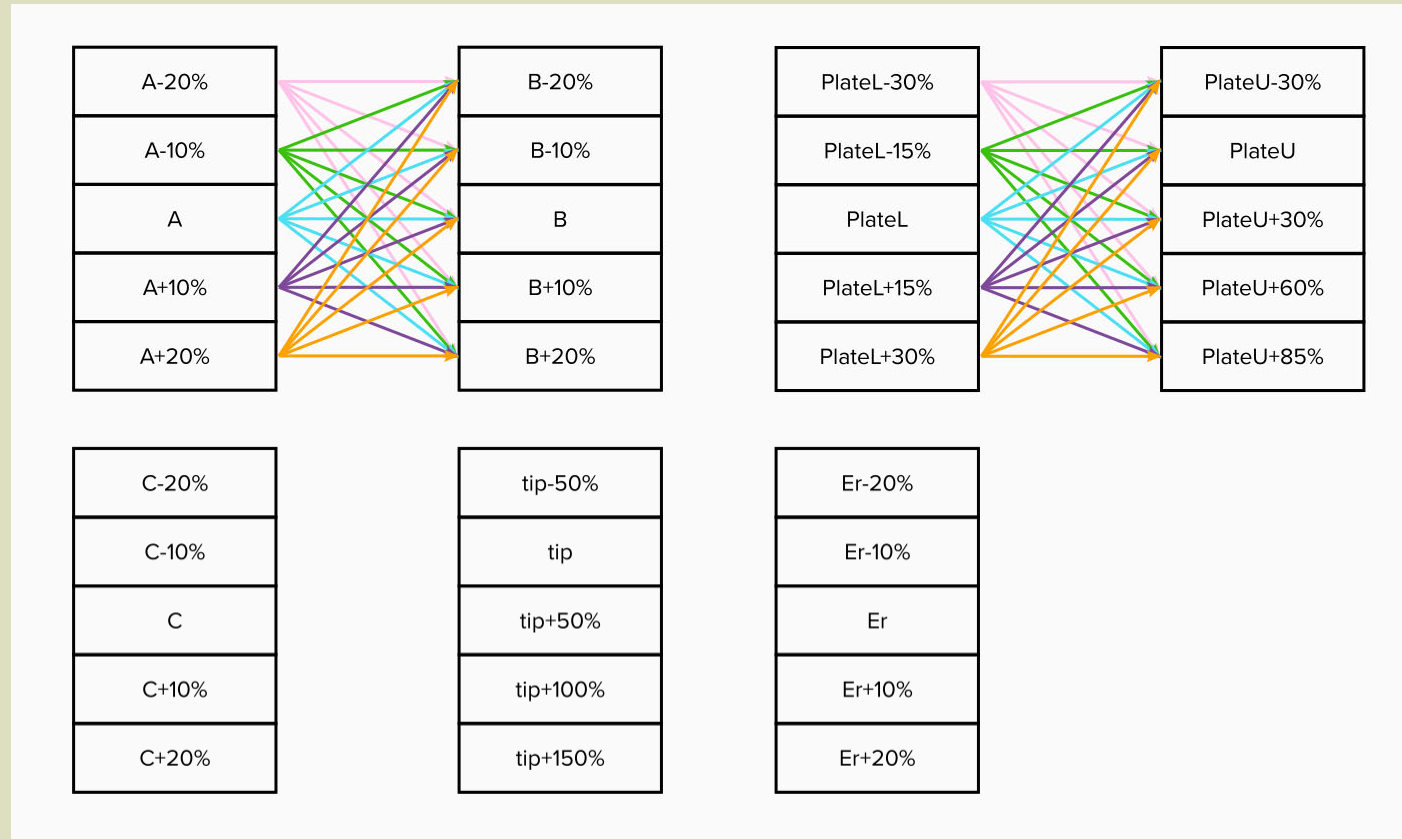
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Test method

- Parametrical variation
 - Body section
 - Tip section
 - Tip length
 - Mechanical structure
 - Material
- GSG vs GSSG comparison
 - Opposite trend
- Final choice is the **best ideal case** from this study



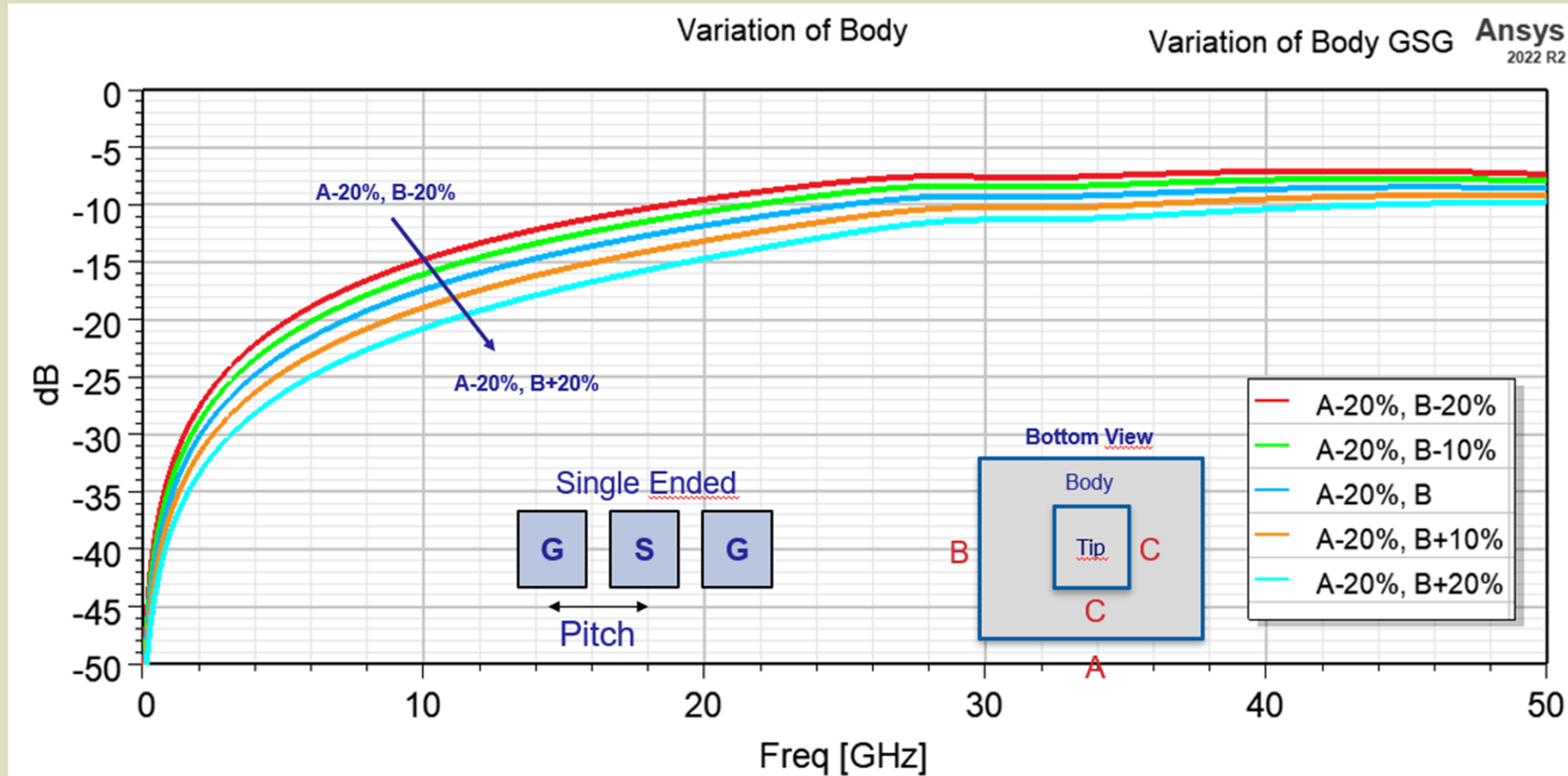
Test method



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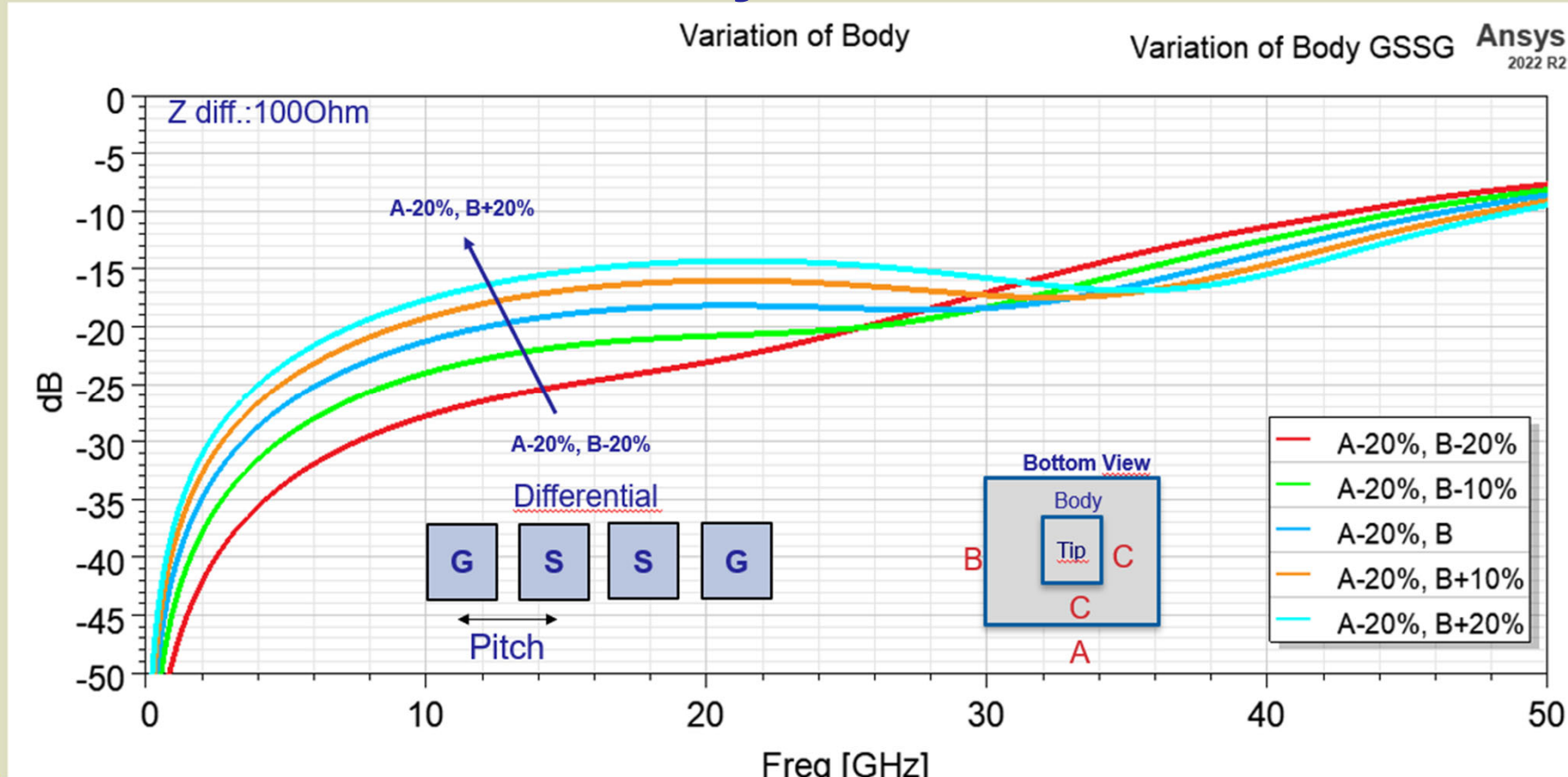
Variation of body dimensions GSG



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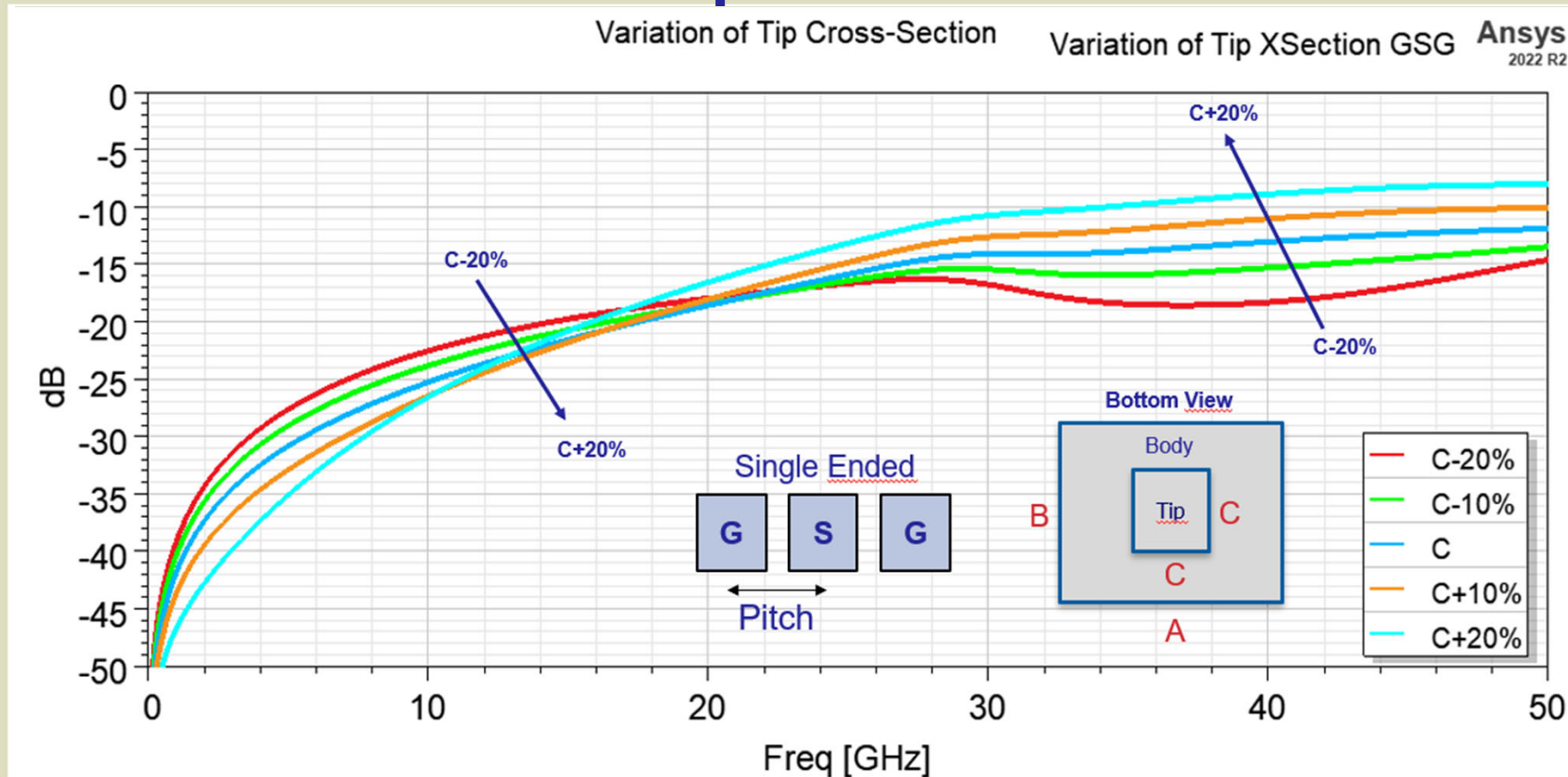
Variation of body dimensions GSSG



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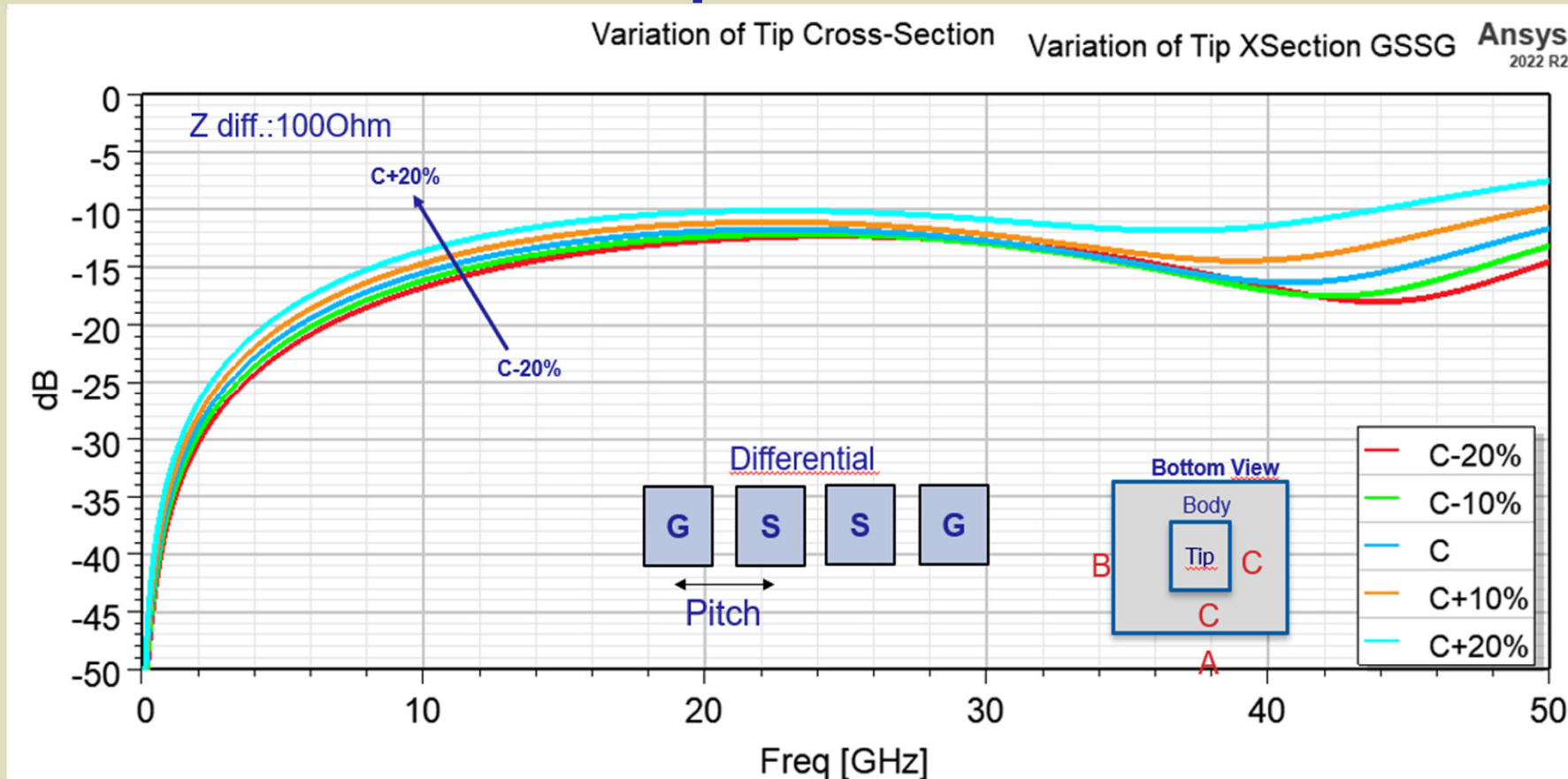
Variation of tip dimensions GSG



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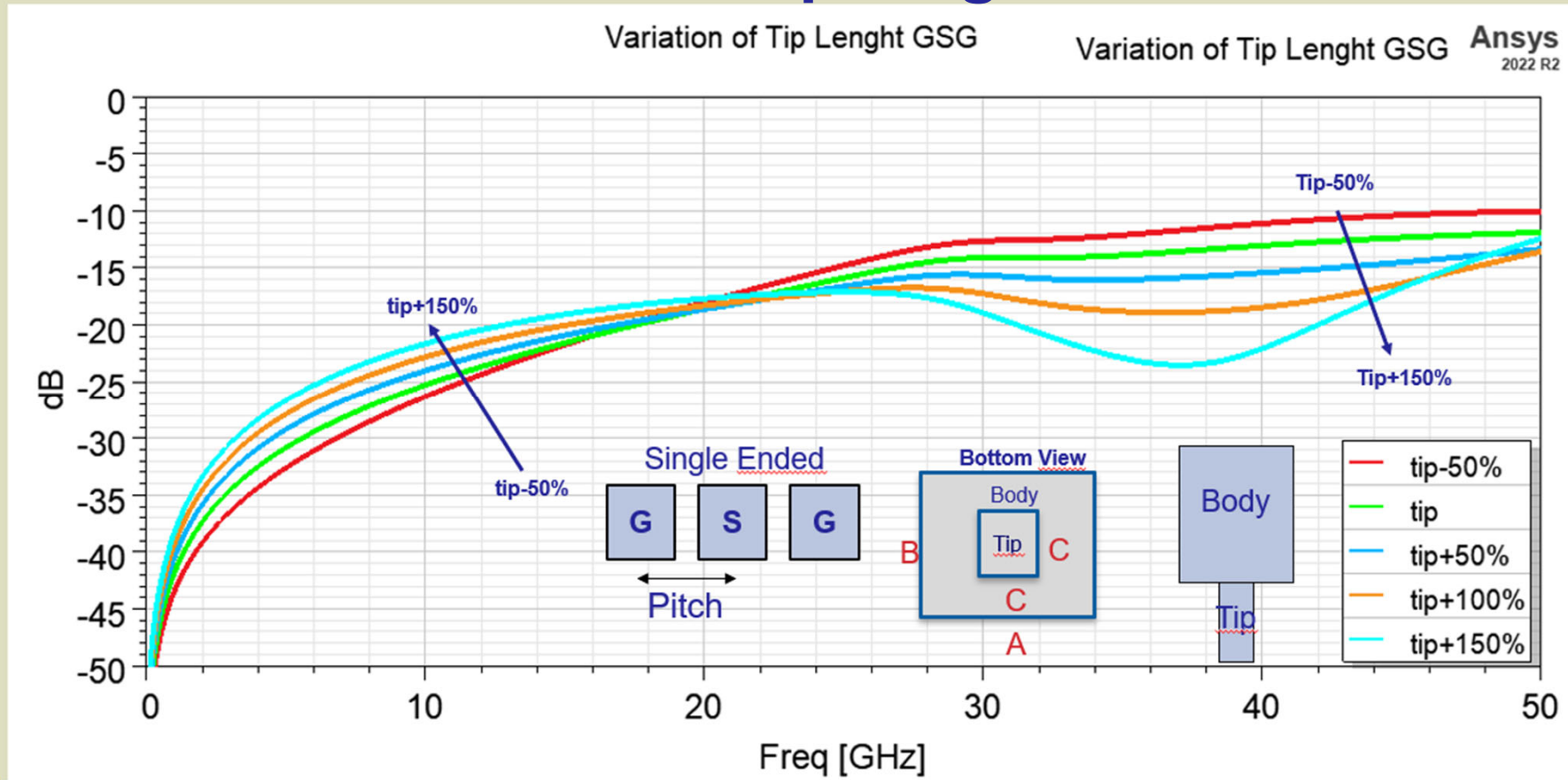
Variation of tip dimensions GSSG



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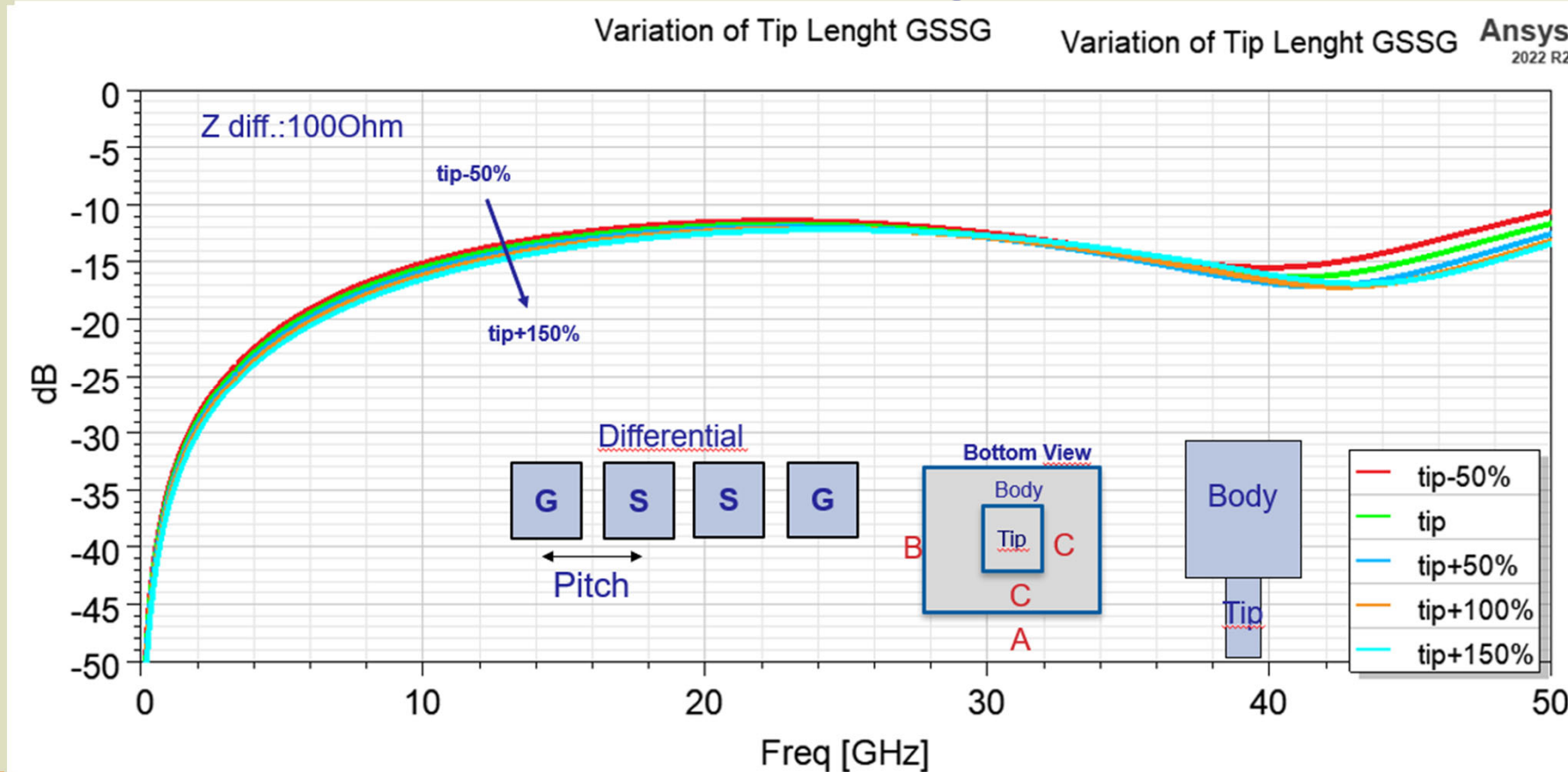
Variation of tip length GSG



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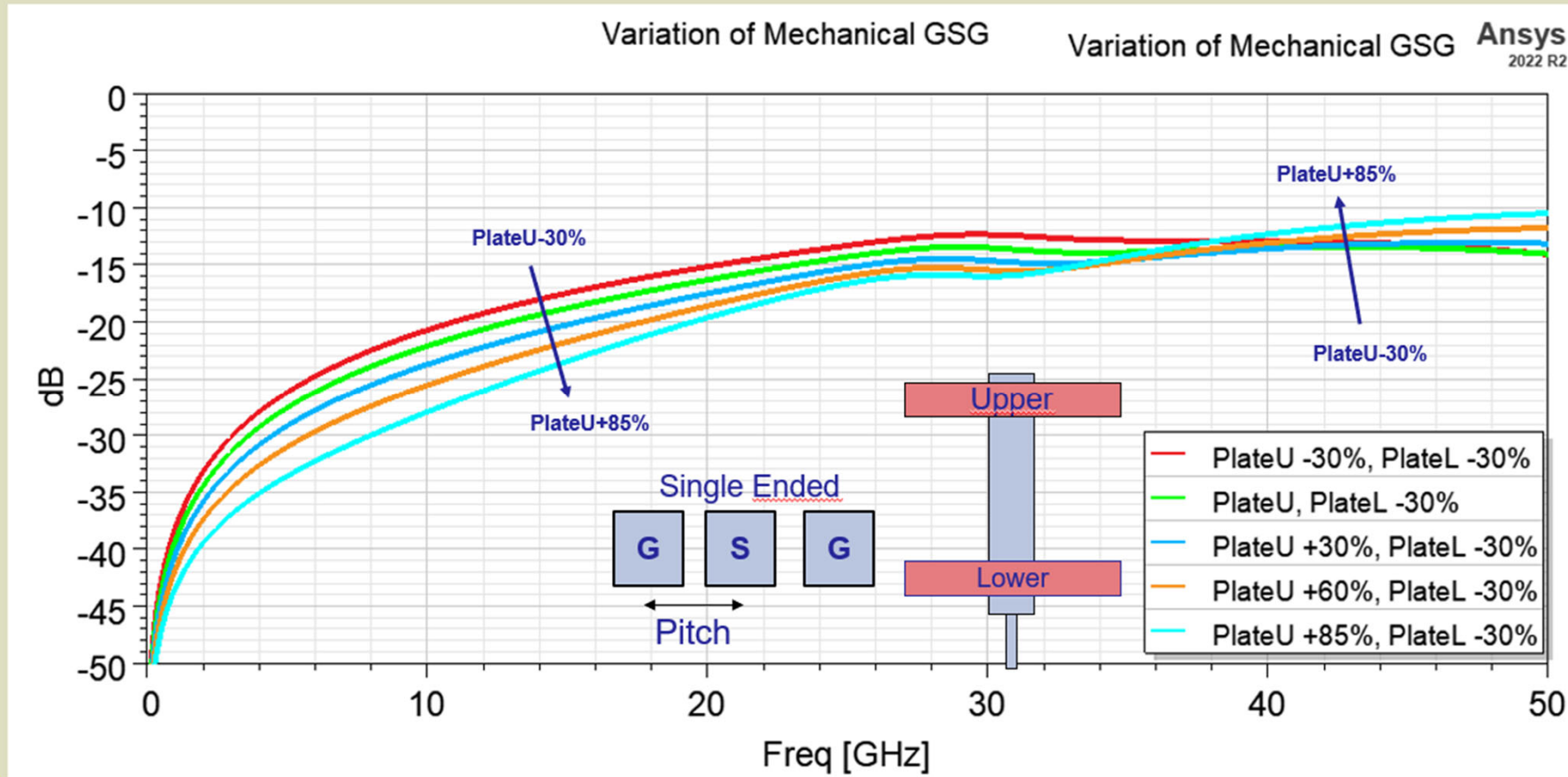
Variation of tip length GSSG



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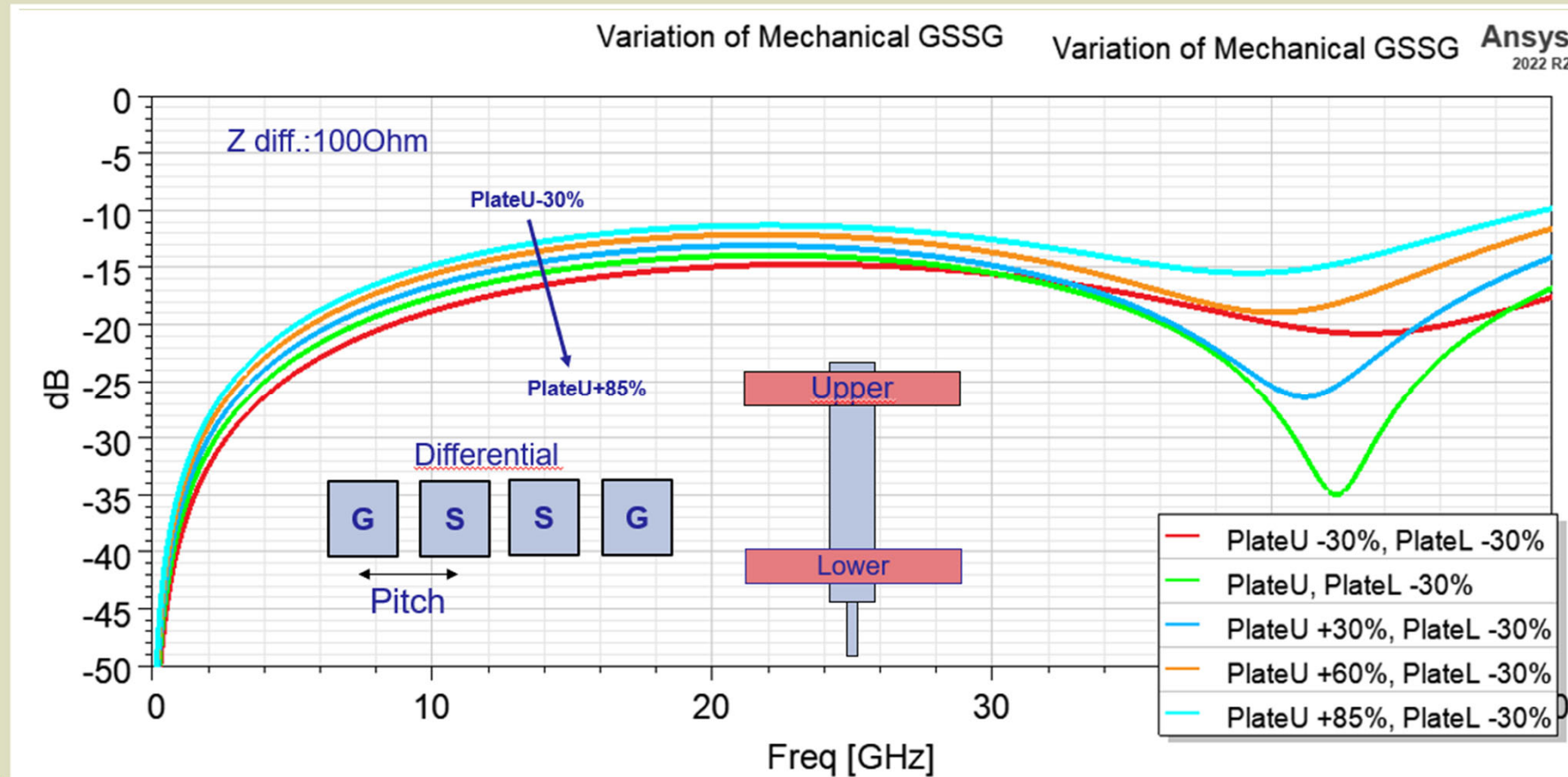
Variation of mechanical structure



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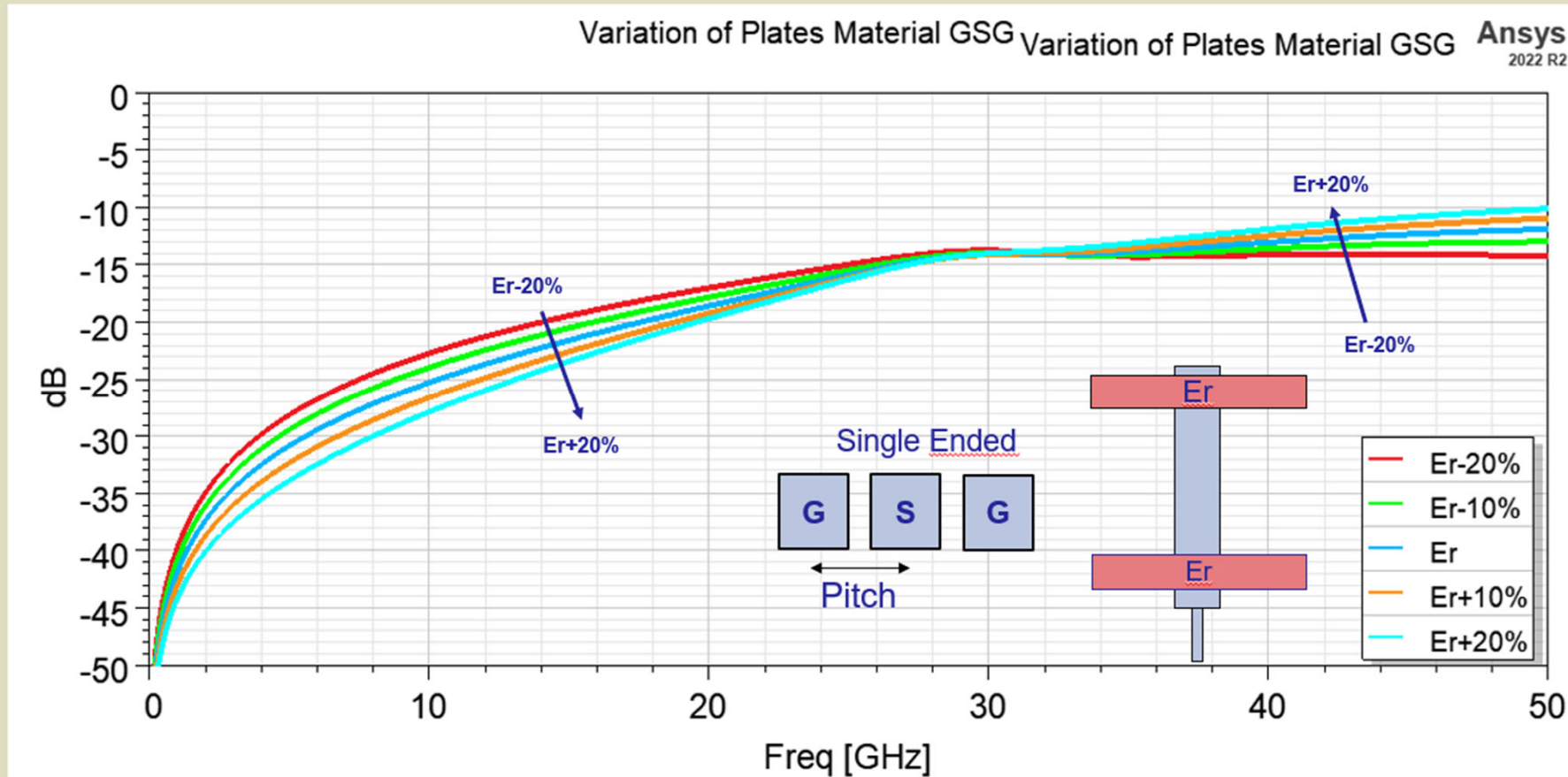
Variation of mechanical structure



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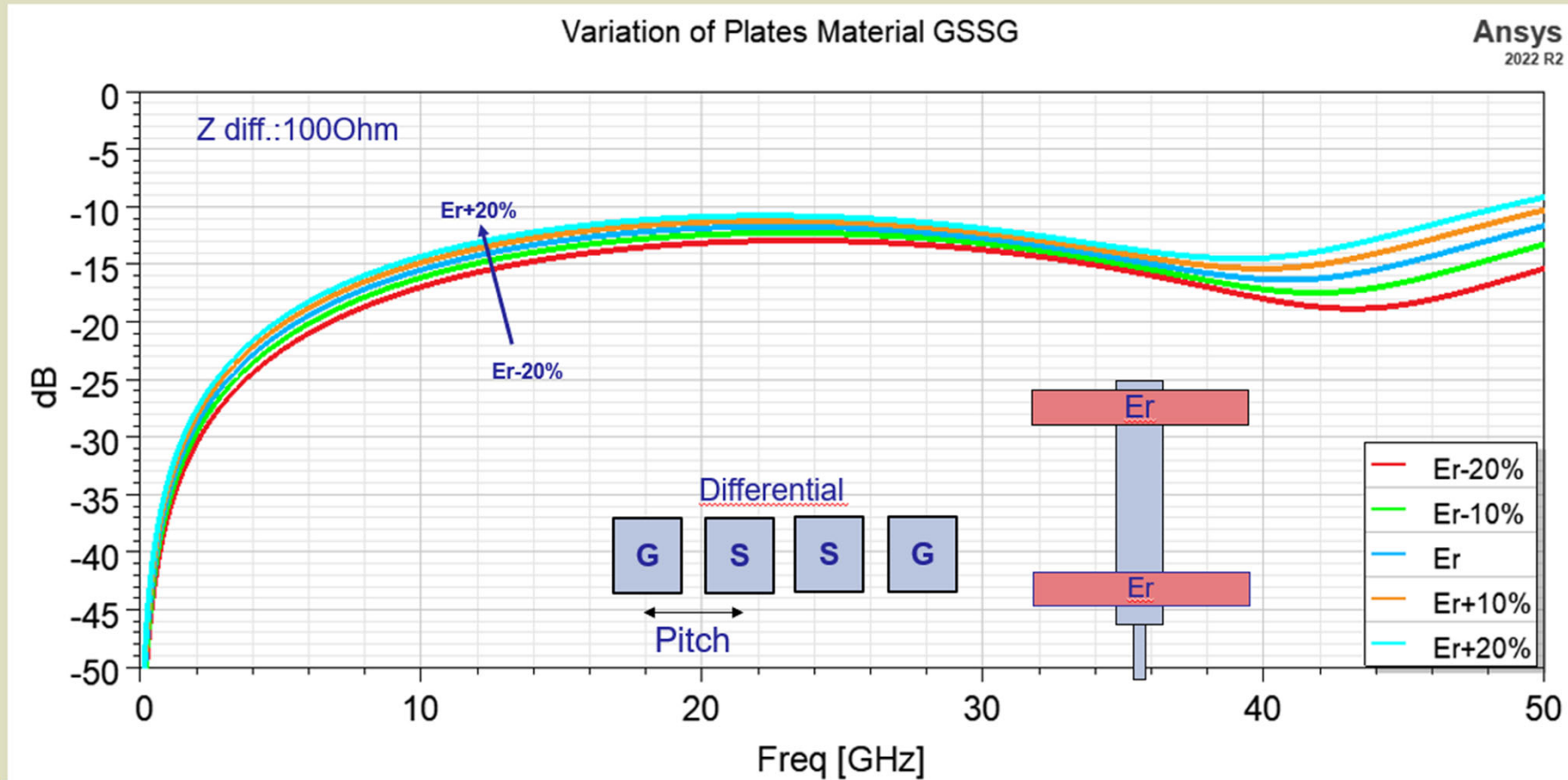
Variation of materials GSG



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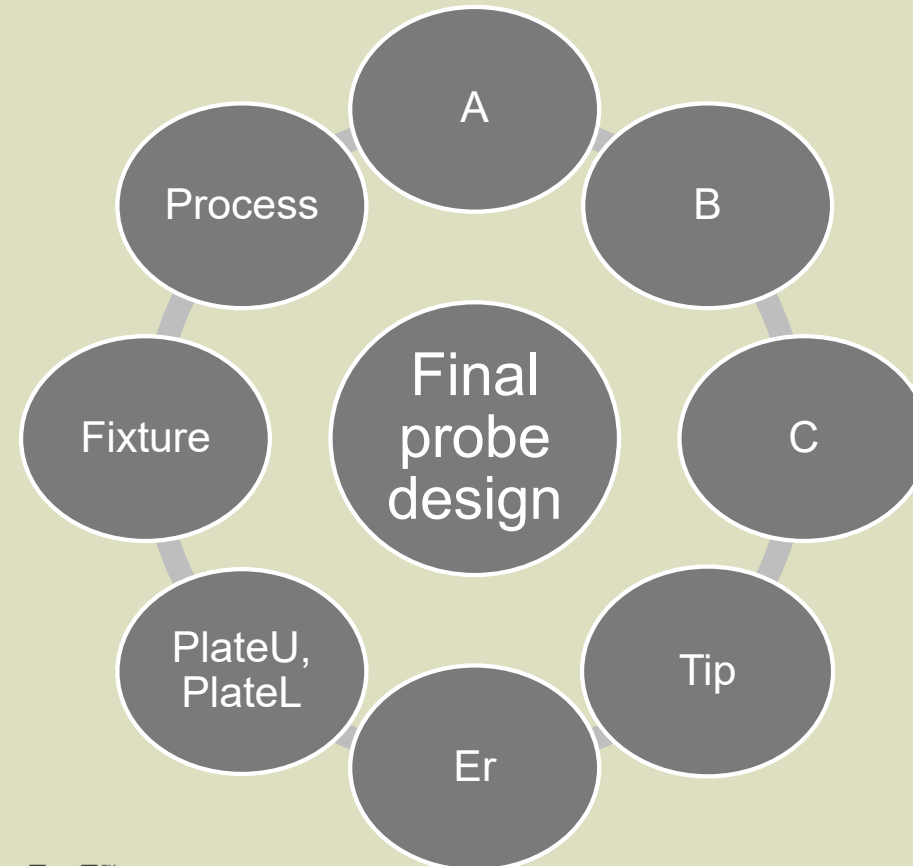
Variation of materials GSSG



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Final choice



Trade off
between GSG
and GSSG

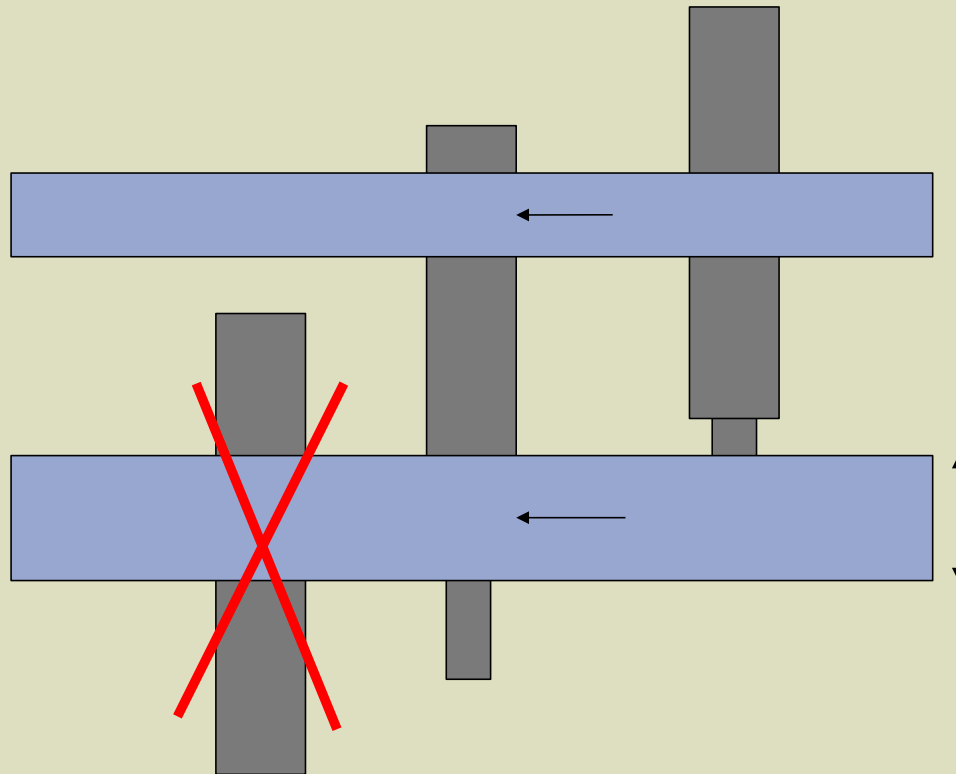


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Final optimization

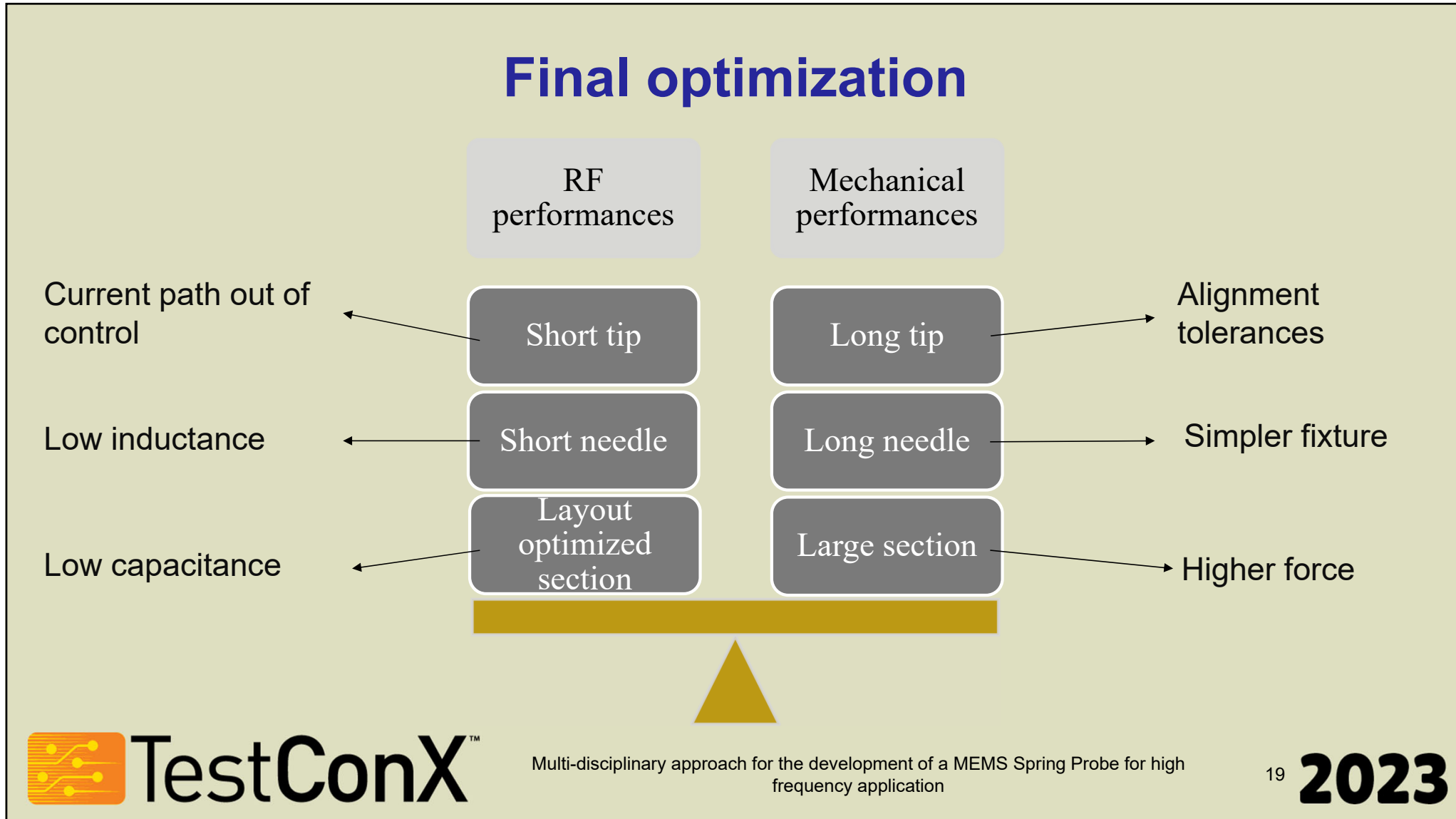


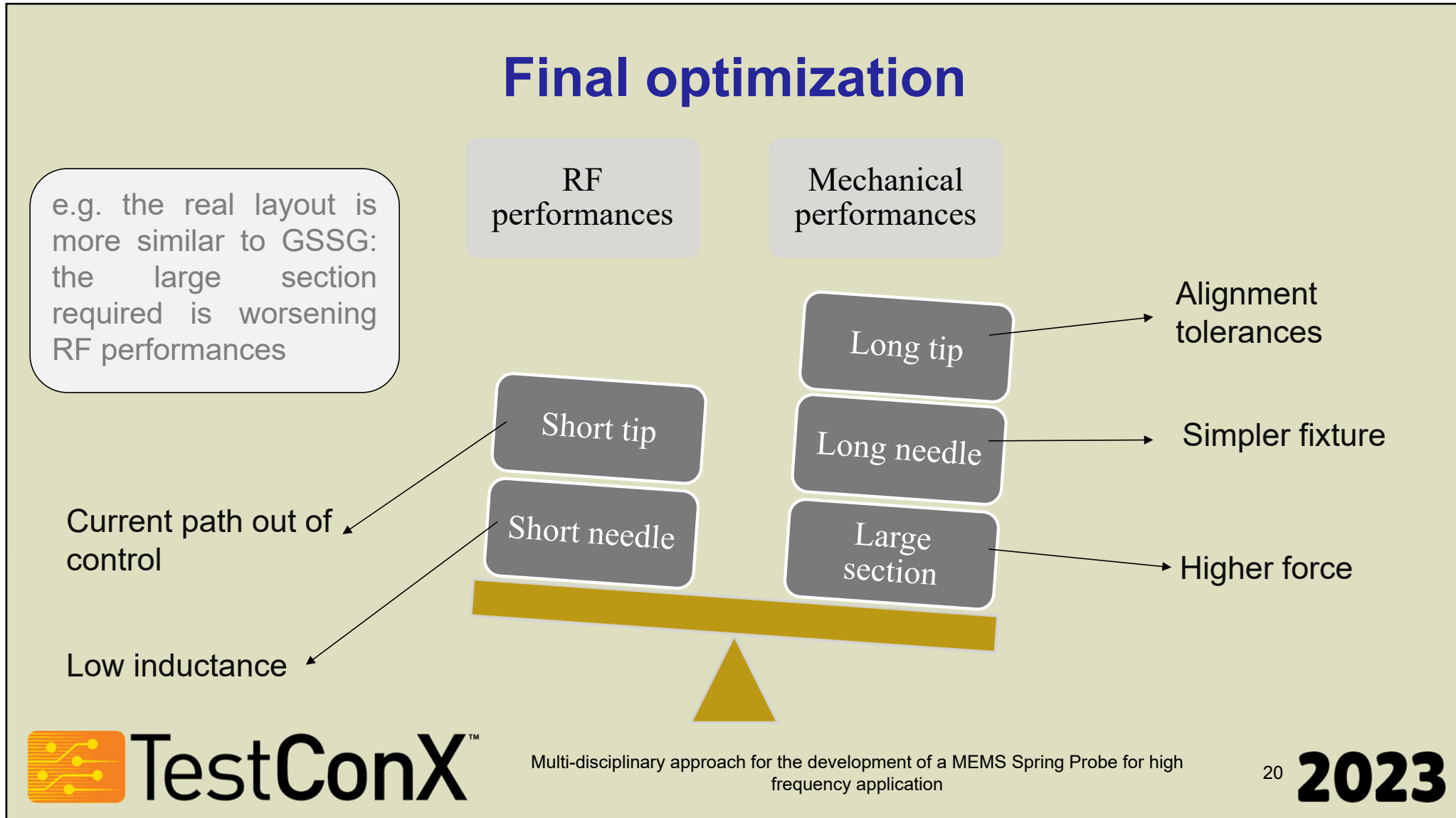
- Avoid falling down of the probe (from both sides)
- Ease of assembly / disassembly
- Avoid warpage
- Electrical-improving features
- Stresses ok to achieve high fatigue life
- Manufacturing limits



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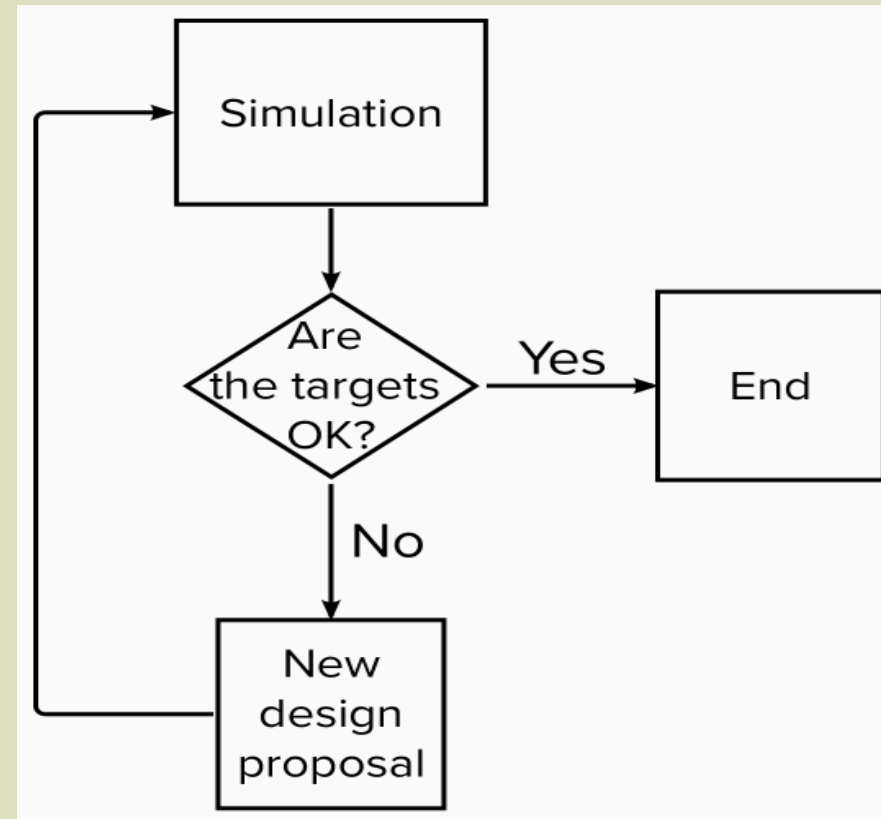




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Complete simulation

- Final probe design
- Final socket design
- Customer layout



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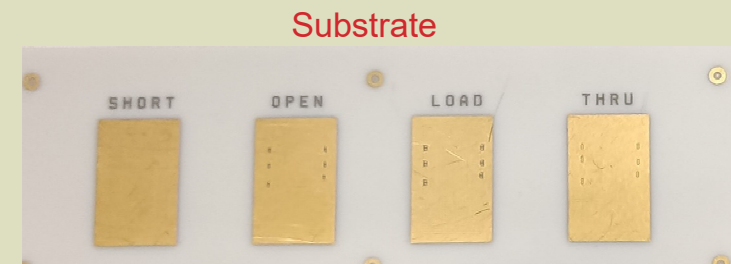
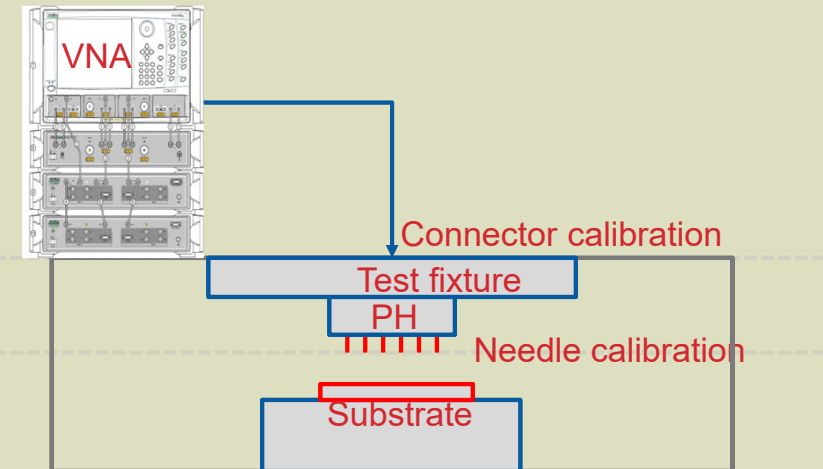
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Measuring Method: 2-tier technique

- In order to measure the RF performance a test fixture is built.
- The technique used is a 2-tier calibration: two 1-Port SOL (short-open-load) calibration are performed, one at connector plane and one at needle plane. S-parameters of what is between these two planes are then obtained.
- Needle calibration is performed with a custom made calibration substrate.



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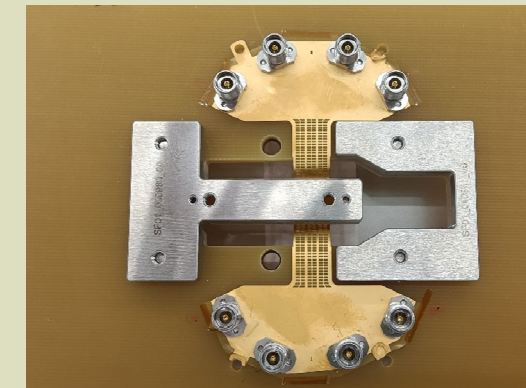
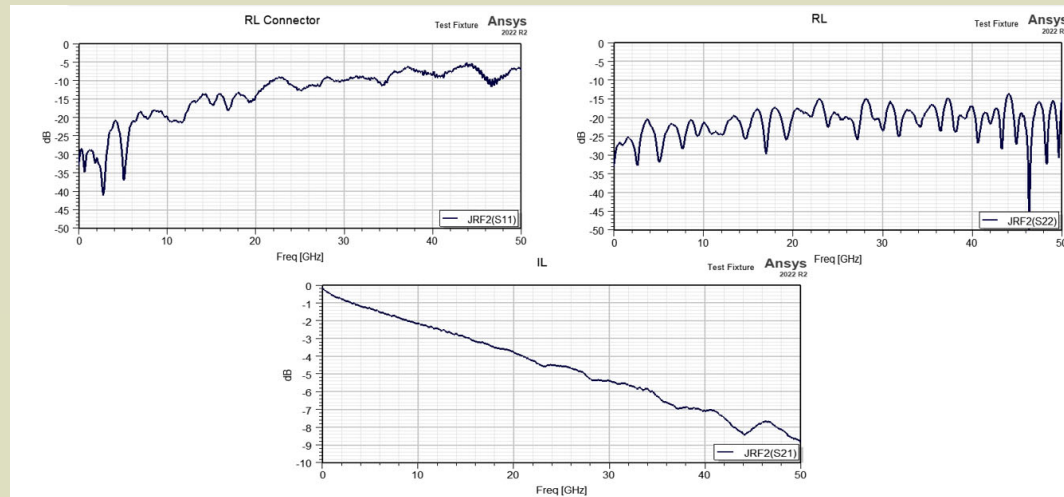
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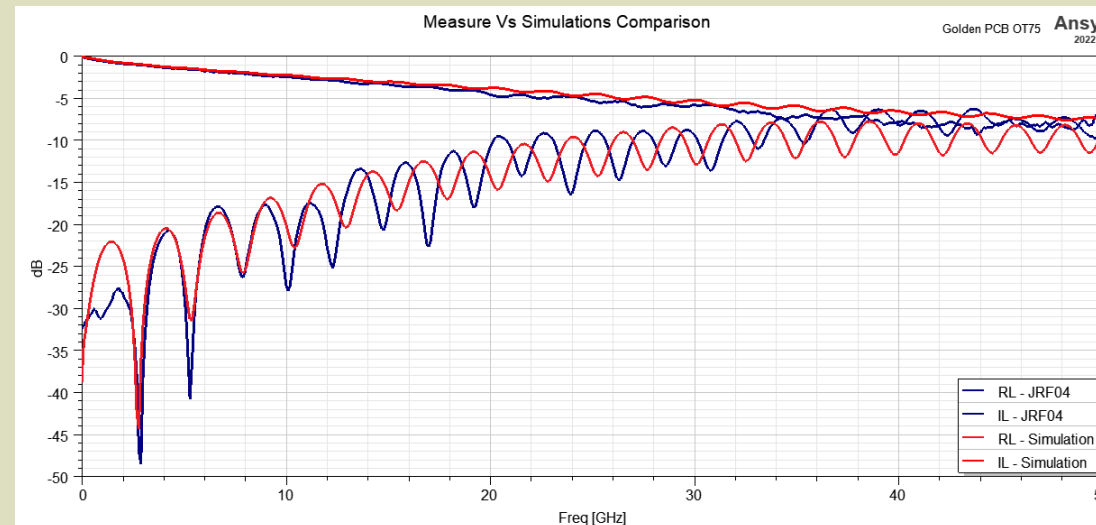
Test Fixture

- Test fixture is composed by a flexible PCB over a FR4 support to give mechanical robustness.
- Below the S-parameters of the test fixture alone:



Measurement comparison

- Below the comparison between measurements and simulation of the total structure.



- It's shown good agreement between them.

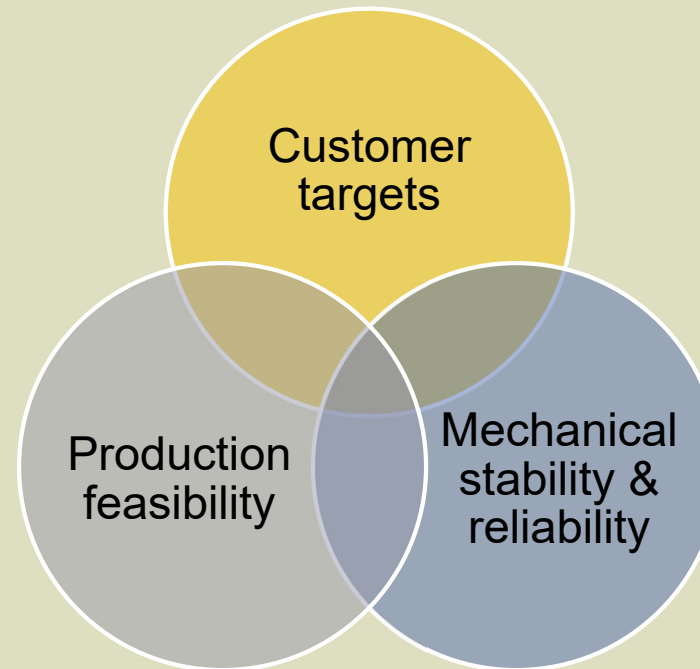


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Conclusion

Developing a new MEMS Spring Probe for RF applications:



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